

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/633,928	MAKI, KEIGO	
Examiner	Art Unit	
Sylvia R. MacArthur	1792	

SEARCHED						
Class	Subclass	Date	Examiner			

INT	ERFERENC	E SEARCH	ED
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		ATE EXMF	₹	
Updated search	8/13.	/2008 STM		